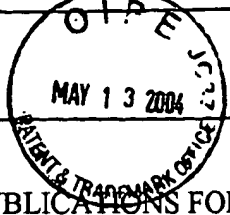


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FORM PTO-1449 Page 1 of 1		Atty. Docket No.:	Serial No.:
		H00026922 (1100.1187101)	10/612,664
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT		Applicant: Jay Schwichtenberg et al.	
		Filing Date:	Group Art:
		July 2, 2003	unknown 2859

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<b>FORM PTO-1449</b>  <b>Page 1 of 8</b>	<b>Atty. Docket No.:</b> H26922 (1100.1187101)	<b>Serial No.:</b> 10/612,664
	<b>Applicant:</b> Jay Schwichtenberg et al.	

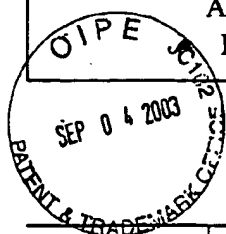
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DISCLOSURE STATEMENT

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FORM PTO-1449

Page 2 of 8


 Atty. Docket No.:  
 H26922  
 (1100.1187101)

 Serial No.:  
 10/612,664

 LIST OF PATENTS AND PUBLICATIONS FOR  
 APPLICANT'S INFORMATION  
 DISCLOSURE STATEMENT

Applicant: Jay Schwichtenberg et al.

Filing Date:

July 2, 2003

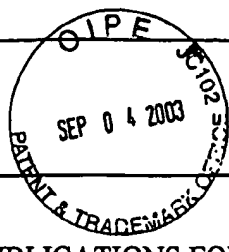
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FORM PTO-1449

Page 3 of 8


 Atty. Docket No.:  
 H26922  
 (1100.1187101)

 Serial No.:  
 10/612,664

 LIST OF PATENTS AND PUBLICATIONS FOR  
 APPLICANT'S INFORMATION  
 DISCLOSURE STATEMENT

Applicant: Jay Schwichtenberg et al.


Filing Date:

July 2, 2003

Group Art:

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<b>FORM PTO-1449</b>  <b>Page 4 of 8</b>		Atty. Docket No.: H26922 (1100.1187101)	Serial No.: 10/612,664
		Applicant: Jay Schwichtenberg et al.	
<b>LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</b>	Filing Date: July 2, 2003		Group Art: <del>unknown</del> 2859

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<b>FORM PTO-1449</b> <b>Page 5 of 8</b>		Atty. Docket No.: H26922 (1100.1187101)	Serial No.: 10/612,664
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT		Applicant: Jay Schwichtenberg et al.	
		Filing Date: July 2, 2003	Group Art: unknown 2859

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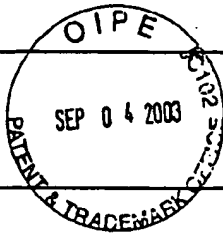
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<b>FORM PTO-1449</b> <b>Page 6 of 8</b>	Atty. Docket No.: H26922 (1100.1187101)	Serial No.: 10/612,664
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	Applicant: Jay Schwichtenberg et al.	
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<b>FORM PTO-1449</b> <b>Page 8 of 8</b>	Atty. Docket No.: H26922 (1100.1187101)	Serial No.: 10/612,664
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